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Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Docket Number (Optional) 3375.6US (95-0999.4)		Application Number Not yet assigned	
Applicant Donald L. Yat s		Filing Date December 19, 2001		Group Art Unit Unknown	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<div style="font-size: 2em; font-family: cursive;">DY</div>	4,132,567	01/1979	Blackwood	<div style="font-size: 2em; font-family: cursive;">1</div>	<div style="font-size: 2em; font-family: cursive;">1</div>	
	4,197,000	04/1980	Blackwood			
	4,286,541	09/1981	Blackwood			
	4,635,666	01/1987	Daley et al.			
	4,682,615	07/1987	Burkman et al.			
	4,911,761	03/1990	McConnell et al.			
	4,984,597	01/1991	McConnell et al.			
	4,997,490	03/1991	Vetter et al.			
	5,069,235	12/1991	Vetter et al.			
	5,095,927	03/1992	Thompson et al.			
<div style="font-size: 2em; font-family: cursive;">DY</div>	5,115,576	05/1992	Roberson, Jr. et al.			

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<div style="font-size: 2em; font-family: cursive;">DY</div>	0,385,536	05/1990	EP	<div style="font-size: 2em; font-family: cursive;">1</div>	<div style="font-size: 2em; font-family: cursive;">1</div>		
	61-154130	07/1986	Japan				
	4-99025	03/1992	Japan				
	4-152525	05/1992	Japan				
<div style="font-size: 2em; font-family: cursive;">AN</div>	4-253332	09/1992	Japan				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
<div style="font-size: 2em; font-family: cursive;">DY</div>		Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15.
<div style="font-size: 2em; font-family: cursive;">DY</div>		Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press. pp. 235-43.
<div style="font-size: 2em; font-family: cursive;">DY</div>		Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55.

EXAMINER	<div style="font-size: 1.5em; font-family: cursive;">D. MARCOLO</div>	DATE CONSIDERED	<div style="font-size: 1.5em; font-family: cursive;">3/10/04</div>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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		Applicant Donald L. Yates		
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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JLL	5,186,192	02/1993	Netsu et al.	1	1	
	5,328,867	07/1994	Chien et al.			
	5,520,744	05/1996	Fujikawa et al.			
	5,660,642	08/1997	Britten			
	5,681,397	10/1997	Li			
	5,752,532	05/1998	Schwenkler			
	5,934,299	08/1999	Akatsu et al.			
	5,951,779	09/1999	Koyanagi et al.			
	5,958,146	09/1999	Mohindra et al.			
	6,125,863	10/2000	Bexten			
AK	6,138,690	10/2000	Nakatani			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
JLL	4-354128	12/1992	Japan	1	1		
	5-47734	02/1993	Japan				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
AK		Leenaars et al., <i>Marangoni Drying: A New Extremely Clean Drying Process</i> , Langmuir, Vol. 6, No. 11, pp. 1701-03.

EXAMINER	<i>A. MARUO</i>	DATE CONSIDERED	<i>3/10/04</i>
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